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Patent Abstracts of Japan

06005530 **PUBLICATION NUMBER** 14-01-94 PUBLICATION DATE

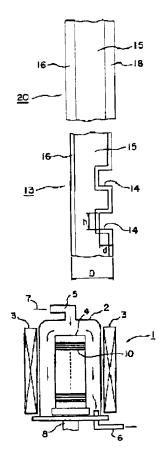
: 17-06-92 APPLICATION DATE : 04158324 APPLICATION NUMBER

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: H01L 21/22 C30B 35/00 H01L 21/324 INT.CL.

: HEAT TREATMENT FURNACE BOAT TITLE



ABSTRACT: PURPOSE: To provide a heat-treatment furnace boat capable of preventing a generation of a fine scratch surrounding a semiconductor substrate to be heat- treated even if the semiconductor substrate is heat-treated within the heat treatment furnace having a non-oxidizing atmosphere.

> CONSTITUTION: A heat-treatment furnace boat 4 placing a semiconductor substrate 10 is used for heat-treating the semiconductor substrate 10 within a heat treatment furnace 1 having a non-oxidizing atmosphere and boat constructing materials 13, 20 constituting this heat-treatment furnace boat 4 comprise at least two layers of a surface layer 16 and an inner layer 15, and the surface layer 16 is characterized by having lower hardness than that of the semiconductor substrate 10 to be heat-treated.

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